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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 8455

HOFFMAN ET AL.

Application No.: 10/759,699

Group Art Unit: 2873

Filed: January 19, 2004

Examiner: HASAN, MOHAMMED A.

Title: CORRECTION OF BIREFRINGENCE IN CUBIC CRYSTALLINE OPTICAL

SYSTEMS

February 16, 2005

REQUEST FOR RETURN OF INITALED PTO-1449

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The Applicants respectfully request that a copy of the PTO-1449, filed November 22, 2004, be returned with the Examiner's initials in the left column per MPEP § 609. A copy of the PTO-1449, as originally filed, is enclosed.

Respectfully submitted,

PILLSBURY WINTHROP LLP

By:

JEAN-PAUL CHOFFMAN

Reg. No. 42663

Tel. No. (703) 905-2094 Fax No. (703) 905-2500

JPH/CFL/smm P.O. Box 10500 McLean, VA 22102 (703) 905-2000

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